

LLECS2024 BELGIUM 5-6 December

transition of advanced semiconductor manufacturing technologies in Spain

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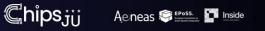




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- PERTE Chip: the Spanish Semiconductor Initiative
- Introduction to InnoFab
- InnoFab's innovative Lab-to-Fab co-operation model
- Summary & Conclusions







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/ European and Spanish initiatives: EU Chips Act & PERTE Chip





The "strategic fund" PERTE Chip is endowed with 12.3 billion euros and aims to turn Spain into a benchmark in the design and manufacturing of chips

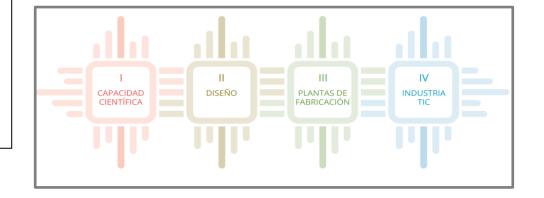
It is fully aligned with the European Chips Act, i.e. directly contributing to its objectives and generating synergies while also complementing other initiatives developed by other Member States and other EU institutions



PERTE Chip Microelectrónica y Semiconductores









/ Spain needs to focus on new markets and define a proper growth strategy

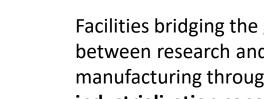
Cleanrooms enabling breakthrough innovation in

advanced materials

Facilities bridging the gap between research and manufacturing through industrialization capabilities

Incorporating new business models supporting high-tech start-ups

Spanish universities, research centres, startups, SMEs and large industry need flexible cleanroom infrastructure for scaling, prototyping & small/medium series manufacturing to overcome the challenge of accessing large foundries during initial industrialization stages



4.1











/ InnoFab's value proposition: *bridging the Lab-to-Fab gap*

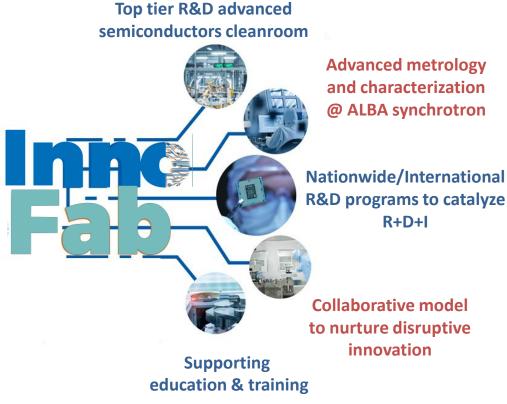
A non-profit R&D center for research and disruptive innovation in next-generation, emerging semiconductor technologies

Strategic objectives:

- **Boost R+D+I** semiconductors ecosystem with state-of-the-art **R&D cleanroom** for development of **innovative technologies** and advanced semiconductors in an industry-relevant environment
- Facilitate Lab-to-Fab transition and industrialization with more flexible collaboration models for universities, research centres, start-ups, SMEs, and large industry.
- Support education and training for all professionals in the business, creating **highly qualified talent at all levels**.

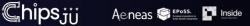
InnoFab will boost current capacity in research, development, scaling-up, prototyping, and talent creation in next-generation semiconductor technologies







InneFab





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Inside

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/ InnoFab is fully embedded within the Spanish academic-, start-up- and industrial-ecosystem



Additional supporters are being engaged





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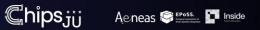
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/ InnoFab will support a network of national & international R&D institutions/chapters



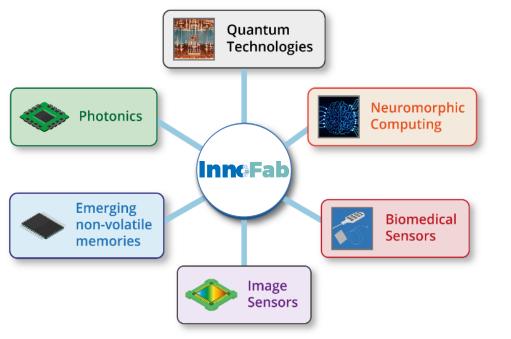
- Chapters are key stakeholders of InnoFab, all will contribute to the technology and innovation pipeline of InnoFab.
- Chapters will have synergistic and/or complementary capacities to those of InnoFab, **mostly working in lower TRLs,** requiring the services of InnoFab to advance in their research
- Collaboration will be in the form of preestablished, long-term collaborative research programs
- InnoFab will co-operate and be complementary to the new IMEC center in Malaga, Spain





/ InnoFab's Technology and Applications focus

InnoFab focusses on technologies and materials with expected market entry in 5 to 15 years



Beyond-CMOS application areas

Neuromorphic computing, quantum technology, advanced photonics, emerging non-volatile memories, sensors, etc.

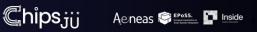
Leading-edge / advanced semiconductors and materials

2D layered materials (graphene, TMD), thin film oxides (metal oxides, ferroelectric oxides), thin film superconducting materials

• Device technologies

High mobility BEOL & beyond Boltzmann transistors, NVM (RRAM, FeRAM, etc), neuromorphic/synaptic devices, qubits, sensors, etc.

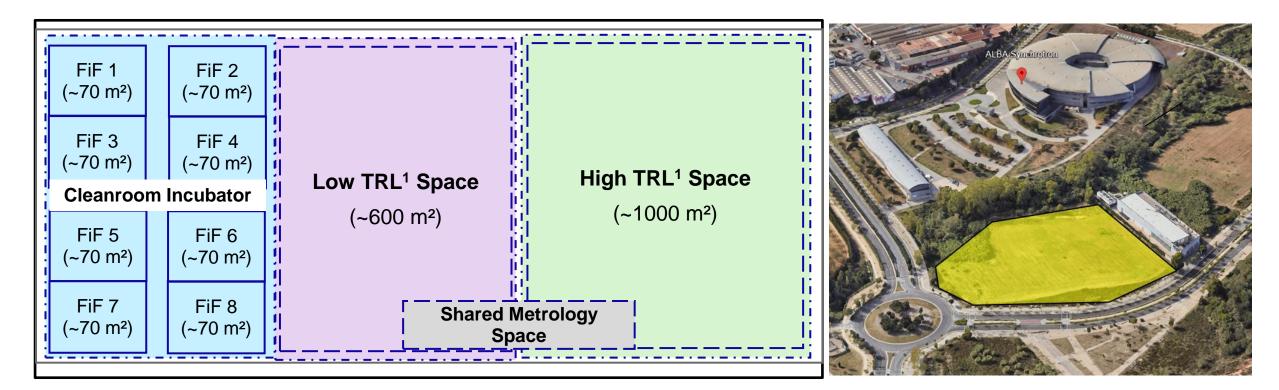






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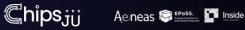




Cleanroom area of 2200 m² integrated in a 10000 m² building of new construction, including cleanroom and its technical areas, testing labs, and offices.

Premium access to leading-edge materials & devices metrology/characterization + available space for potential future expansions





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/ Summary & Conclusions

- With the PERTE Chip fund, Spain is fully committed to become a serious player within the European and global semiconductor industry
- Spain needs to focus on new markets and define a proper strategy, including organic- and inorganic- growth components
- InnoFab will bridge the existing Lab-to-Fab gap in Spain and boost current capacity in R&D, scaleup, prototyping, and talent creation by working with a large network of national & international R&D institutions
- InnoFab will focus on "Beyond-CMOS" technologies and materials, which are expected to enter the volume markets in 5 to 15 years
- InnoFab will hold a state-of-the-art 2200 m² large cleanroom, including a clean-room incubator, a large industrial research lab and a fully-equipped pilot line
- Through innovative business models, InnoFab will enable fast Lab-to-Fab product transition for onsite and external partners, while creating HVM processes and low-volume prototypes



